



Attorney Docket No. 0756-2332

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Takeshi FUKADA et al.

Serial No. 09/904,906

Filed: July 16, 2001

For: GLASS SUBSTRATE ASSEMBLY,  
SEMICONDUCTOR DEVICE AND  
METHOD OF HEAT-TREATING  
GLASS SUBSTRATE

) Group Art Unit: 2825

) Examiner: L. Malsawma

) CERTIFICATE OF MAILING

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2003.

) Adrian Stamps

AMENDMENT

Honorable Commissioner of Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated July 30, 2003, please consider the following amendments and remarks in connection with the above-identified application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 9 of this paper.

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03 FC:1201 172.00 OP

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